IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Yasuhiko KASAMA et al.

Conf.

Application No. NEW NATIONAL PHASE

Group

Filed July 5, 2006

Examiner

ION IMPLANTATION SYSTEM AND ION IMPLANTATION SYSTEM

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

July 5, 2006

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begin on page 3 of this paper.

Remarks begin on page 9 of this paper.

An Appendix is attached following the signature page of this paper.